## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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First Named Inventor Hirayama et al.

Art Unit 1795

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Attorney Docket No. SHIGA7.055APC

(Multiple sheets used when necessary)
SHEET 1 OF 1

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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear				

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NON PATENT LITERATURE DOCUMENTS							
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Examiner Signature /Connie Johnson/ (09/15/2008) Date Considered 09/15/2008

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